Inventor: Tae-Hee Park For: Methods of Forming Metal Lines in Semiconductor Devices Attorney Docket No. 20067/OPP031479US Sheet 1 of 2

FIG.1A

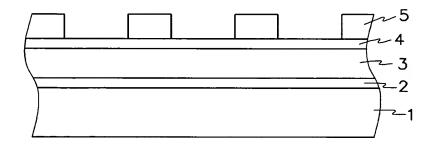


FIG.1B

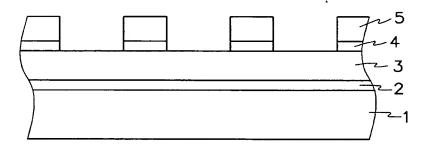
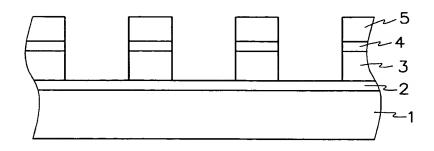


FIG.1C



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FIG.1D

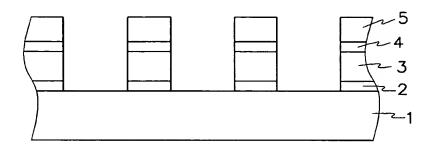


FIG.1E

